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2826

PATENT
(5298-08000/PM01040)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ramkumar

Serial No. 10/074,884

Filed: February 13, 2002

For: SEMICONDUCTOR TOPOGRAPHY
INCLUDING A THIN OXIDE-NITRIDE
STACK AND METHOD FOR MAKING
THE SAME

§ Group Art Unit: 2826
§ Examiner: Erdem, Fazli.
§
§ Atty. Dkt. No. 5298-0800

Atty. Dkt. No. 5298-08000

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: **Box: Non-Fee Amendment, Commissioner for Patents, Washington, D.C. 20231**, on the date indicated below:

September 18, 2003
Date

Kevin L. Daffer

AMENDMENT; RESPONSE TO OFFICE ACTION MAILED JUNE 18, 2003

Box: Non-Fee Amendment
Commissioner for Patents
Washington, D.C. 20231

Dear Sir/Madam:

This paper is submitted in response to the Office Action mailed June 18, 2003 to further highlight reasons why the application is in condition for allowance.

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TECHNOLOGY CENTER highlight
highlight

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.